



PATENT APPLICATION *ITW*

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Date November 17, 2008

In re the Application of

Hideharu ITATANI et al.

Group Art Unit: 2891

Application No.: 10/521,248

Examiner: C. EVERHART

Filed: April 11, 2005

Docket No.: 122430

For: METHOD OF MANUFACTURING SEMICONDUCTOR DEVICE AND SUBSTRATE  
PROCESSING APPARATUS

**LARGE ENTITY PETITION FOR 1<sup>st</sup> - 3<sup>rd</sup> EXTENSION  
OF TIME UNDER 37 C.F.R. §1.136(a) AND  
TRANSMITTAL OF FEE UNDER 37 C.F.R. §1.17**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

Transmitted herewith is a response to the outstanding Official Action in the above-identified patent application. The shortened statutory period having expired October 16, 2008, an extension of time for a period of 1 month is hereby requested. Attached hereto is our Check No. 212163 in the amount of \$130 in payment for:

- X Extension fee for response within first month pursuant to §1.136(a) (\$130.00)  
       Extension fee for response within second month pursuant to §1.136(a) (\$490.00)  
       Extension fee for response within third or subsequent month pursuant to §1.136(a) (\$1,110.00)

The Commissioner is hereby authorized to charge any additional fee or credit any overpayment associated with this communication to Deposit Account No. 15-0461.

Respectfully submitted,

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DEPOSIT ACCOUNT USE  
AUTHORIZATION  
Please grant any extension  
necessary for entry;  
Charge any fee due to our  
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